# AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE GROUP 1792 PATENT APPLICATION

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92709

Masahiko ISHIDA, et al.

Appln. No.: 10/564,750

Group Art Unit: 1792

Confirmation No.: 1790

Examiner: Felisa Carla HITESHEW

Filed: January 17, 2006

For:

**FOR** FIXING METAL **PARTICLES** AND **METHOD** FOR **METHOD** MANUFACTURING SUBSTRATE CONTAINING METAL PARTICLES, METHOD FOR MANUFACTURING SUBSTRATE CONTAINING CARBON NANOTUBE, AND **CONTAINING MANUFACTURING SUBSTRATE METHOD** FOR SEMICONDUCTOR-CRYSTALLINE ROD, EMPLOYING

### AMENDMENT UNDER 37 C.F.R. § 1.116

#### **MAIL STOP AF**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 8, 2009, please amend the above-identified application as follows on the accompanying pages.

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